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FEI Avizo[®] 3D visualization of two large adjacent crystalline dendrites of a bulk-metallic-glass matrix composite (Zr₉₈₅Ti₁₄₃Mb₅₂Cu_{6.1}Ni_{4.9}Be_{11.0}). Data was obtained by large volume serial sectioning tomography using the Helios PFIB DualBeam. The sectioned block is about 90×80×70 µm³. Sample from The University of Tennessee, USA. Images courtesy of The University of Manchester.

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Scanning electron microscopy image of immature strawberry flower. Clockwise from upper left: original image width = 2.54 mm; 2× enlargement; 4× enlargement; and 8× enlargement.

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Zika virus 3.70 Å, 10 MDa

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